

| | | | |
|-----------------------------------|---------------------------------------|---|-------------|
| Notice of References Cited | Application/Control No. 10/812,703 | Applicant(s)/Patent Under Reexamination PARK ET AL. | |
| | Examiner Alonzo Chambliss | Art Unit 2814 | Page 1 of 1 |

U.S. PATENT DOCUMENTS

| * | | Document Number Country Code-Number-Kind Code | Date MM-YYYY | Name | Classification |
|---|---|--|-----------------|-------------------|----------------|
| * | A | US-6,548,362 | 04-2003 | Wu, Shye-Lin | 438/304 |
| * | B | US-6,781,191 | 08-2004 | Lin, Chi-Hui | 257/321 |
| * | C | US-6,964,913 | 11-2005 | Dong et al. | 438/437 |
| * | D | US-5,940,717 | 08-1999 | Rengarajan et al. | 438/435 |
| * | E | US-6,319,794 | 11-2001 | Akatsu et al. | 438/424 |
| * | F | US-6,509,232 | 01-2003 | Kim et al. | 438/264 |
| | G | US- | | | |
| | H | US- | | | |
| | I | US- | | | |
| | J | US- | | | |
| | K | US- | | | |
| | L | US- | | | |
| | M | US- | | | |

FOREIGN PATENT DOCUMENTS

| * | | Document Number Country Code-Number-Kind Code | Date MM-YYYY | Country | Name | Classification |
|---|---|--|-----------------|---------|------|----------------|
| | N | | | | | |
| | O | | | | | |
| | P | | | | | |
| | Q | | | | | |
| | R | | | | | |
| | S | | | | | |
| | T | | | | | |

NON-PATENT DOCUMENTS

| * | | Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages) |
|---|---|---|
| | U | |
| | V | |
| | W | |
| | X | |

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.